OW

Application Number

	, DIEG	ABAG MENON DAGGE COLD			14846-17		60/459,328			
IDS -	-10814	<b>PRYPATION DISCLOSUR</b> (Use several sheets if necess			Applicant(s) L. Love, et al.			<del></del>		
		(			Filing Date		Group Art Unit			
					04/01/2003					
	<del></del>			U.S. PAT	FENT DOCUMENTS			<del>,</del>		
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	1	G DATE ROPRIATE	
MEK	Λ	US 5,768,119	6/16/1998	Haveko	ost, et al.					
MEK	В	US 6,046,742	4/4/2000	S. Char	i					
MEK	c ·	US 6,184,996 B1	2/6/2001	S. Gase						
MEK	D	US 5,325,527	6/28/1994	R. Cwil	kowski, et al.					
MEK	E	US 5,553,235	9/3/96	J. N. Cł	hen, et al.					
MEK	P	US 5,790,809	8/4/1998	R. Holm	nes					
MEK	G	US 5,946,458	8/31/1999	P. Austi	P. Austin, et al.					
	н	US 5,999,179	12/7/1999	M. Keki	M. Kekic, et al.					
	1	US 6,288, 790 B1	9/11/2001	K. Kish	ore, et al.					
	J	US 6,332,161 B1	12/18/2001	G. Sasson						
MEK	к	US 6,453,127 B2	9/17/2002	C. Wood	d, et al.					
		<del></del>		FOREIGN	N PATENT DOCUMENTS					
	REP	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	YES	NO	
			,							
		I								
		- 11 11 La 1				Author, Title, Da	ste, Pertinent Pa	iges, Etc.)		
	T	Strict Read Order Cont	trol for a Queing	System,spi.	.org				-	
MEK	,									
	+	Beginning of Viewing I	nformationa and '	Viewing Bs	asic Information about a P	rint from 5 M	anaging Print	Queues,sp	i.org	
MEK	2									
EXAMINER	<u></u>	/Michael Keefer	. ,		DATE CONSIDERED	01/03/200	^7			
					·					
XAMINER tot consider	l: Initial	al if citation considered, whether c clude copy of this form with next o	or not citation is in communication to s	conformanc applicant.	e with MPEP Section 609; Dr	raw line through	h citation if not	in conforms	ance and	

Docket Number (Optional)

				Docket Number (Optional)	/	Application Number				
		· · · · · · · · · · · · · · · · · · ·		14846-17		60	/45,328			
	INFU	DRMATION DISCLOSURE (Use several sheets if necessa		,	Applicant(s) L. Love, et al.					
		OSC SCIENCES SHOULD BY HOUSE	יעי	,	Filing Date		Group Art Unit			
				·	4/1/2003					
				U.S. PAT	ENT DOCUMENTS					
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	1	G DATE	
MEK	L	US 6,470,384 B1	10/22/2002	E. O'Br	rian, et al.				Ji Kun :	
MEK	М	US 6,477,590 B1	11/5/2002	U. Habı	usha, et al.		·			
MEK	N	US 6,518,983 B1	2/11/2003	R. Grut	hmann, et al.					
MEK	0	US 6,185,613 B1	2/6/2001	T. Laws	son, et al.					
	1		<del></del>	FOREIGN	N PATENT DOCUMENTS	· ·				
	REF	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	Transl YES	slation NO	
				<u></u>						
								·		
	$\dashv$							<u> </u>		
				<u> </u>	e .					
	<del></del>	Cud annual and annual		OTHER D	OCUMENTS (Including A)	uthor, Title, Do	ate, Pertinent Pag	ges, Etc.)		
MEK	3	x4queview spi.org								
XAMINER	l l	/Michael Keefer/			DATE CONSIDERED 0	01/03/200	<b>)</b> 7			
KAMINER ot consider	:: Initia ed. Inc	al if citation considered, whether or clude copy of this form with next co	r not citation is in a	conformanc	e with MPEP Section 609; Dr	aw line throug	h citation if not	in conforms	ance and	

Form PTO-A820 (also form PTO-1449)